

Notice of References Cited	Application/Control No. 10/064,452	Applicant(s)/Patent Under Reexamination LIAW ET AL.	
	Examiner Alonzo Chambliss	Art Unit 2827	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,796,171	08-1998	Koc et al.	257/786
*	B	US-2004/0004296	01-2004	Cheng et al.	257/786
*	C	US-6,638,793	10-2003	Chen, Chung-Hui	438/123
*	D	US-5,814,892	09-1998	Steidl et al.	257/784
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	I	US-			
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	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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	N					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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